



PATENT  
Attorney Docket No. 04329.2409-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
 )  
Kei YOSHIKAWA et al. ) Group Art Unit: 2624  
 )  
Application No.: 09/662,219 ) Examiner: Samir Anwar AHMED  
 )  
Filed: September 14, 2000 )  
 )  
For: PATTERN CORRECTING ) Confirmation No.: 9438  
METHOD OF MASK FOR )  
MANUFACTURING A )  
SEMICONDUCTOR DEVICE AND )  
RECORDING MEDIUM HAVING )  
RECORDED ITS PATTERN )  
CORRECTING METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

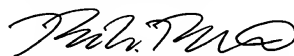
Applicants petition for a three-month extension of time to file a reply to the final Office Action dated August 28, 2006. The required fee of \$1,020.00 is enclosed.

Please grant any additional extensions of time required to enter the attached reply and charge any additional required fees to Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 28, 2007

By:   
Reece Nienstadt  
Reg. No. 52,072

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